



**PATENT APPLICATION**

*AFS*

**CERTIFICATE OF MAILING/FACSIMILE TRANSMISSION (37 CFR 1.8)**

I hereby certify that this paper (along with any paper referred to as being transmitted therewith) is (~~XXXX~~) being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box. 1450, Alexandria, Virginia 22313-1450 or () being transmitted by facsimile to the U.S. Patent and Trademark Office. (Fax No. 703 872 9306) ( pages). This facsimile is being sent from (908) 429-3650.

Maria T. Sanchez  
(Print Name)

Date: November 14, 2005

*Maria T. Sanchez*  
(Signature)

Attorney's Docket No. 2003US301CIP

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application for

Ralph R. DAMMEL et al.

Serial No.: 10/658,840

Group Art Unit: 1752

Filed: September 9, 2003

Examiner: John S Y Chu

For: **Photoresist Composition for Deep Ultraviolet Lithography**

**AMENDMENT AFTER FINAL**

November 14, 2005

Mail Stop Amendment  
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